

- 4.39 A silicon semiconductor material at  $T = 300$  K is doped with arsenic atoms to a concentration of  $2 \times 10^{15} \text{ cm}^{-3}$  and with boron atoms to a concentration of  $1.2 \times 10^{15} \text{ cm}^{-3}$ . (a) Is the material n type or p type? (b) Determine  $n_0$  and  $p_0$ . (c) Additional boron atoms are to be added such that the hole concentration is  $4 \times 10^{15} \text{ cm}^{-3}$ . What concentration of boron atoms must be added and what is the new value of  $n_0$ ?

a) Per Table 4.3, arsenic is a donor while boron is an acceptor. Since,  $N_{As} > N_B$ , the material is n-type.

b) From Table B.4,  $n_i = 1.5 \times 10^{10} \text{ #/cm}^3$ .

Assuming complete ionization along w/  $N_d > N_a$ , we use (4.60)

$$n_0 = \frac{N_d - N_a}{2} + \sqrt{\left(\frac{N_d - N_a}{2}\right)^2 + n_i^2}$$

$$= \frac{(2 - 1.2) \times 10^{15}}{2} + \sqrt{\left(\frac{0.8 \times 10^{15}}{2}\right)^2 + (1.5 \times 10^{10})^2}$$

$$\underline{n_0 = 8 \times 10^{14} \text{ #/cm}^3}$$

$$(4.43) \quad n_0 p_0 = n_i^2 \Rightarrow p_0 = \frac{(1.5 \times 10^{10})^2}{8 \times 10^{14}} \Rightarrow \underline{p_0 = 2.8125 \times 10^5 \text{ #/cm}^3}$$

c) Call the additional boron  $\Delta N_a$  and assume complete ionization. Per (4.62)

$$p_0 = \frac{N_a - N_d}{2} + \sqrt{\left(\frac{N_a - N_d}{2}\right)^2 + n_i^2} \approx N_a - N_d$$

$$4 \times 10^{15} = (1.2 \times 10^{15} + \Delta N_a) - 2 \times 10^{15}$$

$$\underline{\Delta N_a = 4.8 \times 10^{15} \text{ #/cm}^3}$$

$$(4.43) \quad n_0 = \frac{(1.5 \times 10^{10})^2}{(4.8 + 1.2) \times 10^{15}} \Rightarrow \underline{n_0 = 3.75 \times 10^4 \text{ #/cm}^3}$$